



**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hidekazu MORIYAMA

Group Art Unit: 1762

Application No.: 10/827,317

Examiner: J. LIN

Filed: April 20, 2004

Docket No.: 119294

For: PATTERN FORMATION METHOD, DEVICE MANUFACTURING METHOD,  
ELECTRO-OPTICAL DEVICE, AND ELECTRONIC APPARATUS

**REQUEST FOR RECONSIDERATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the February 22, 2007 Office Action, reconsideration of the rejections is respectfully requested in light of the following remarks.